



**ELECTRONIC COPY**

LG632438802  
Report verification at igi.org



June 12, 2024

IGI Report Number **LG632438802**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **6.97 X 6.87 X 4.86 MM**

**GRADING RESULTS**

Carat Weight **2.04 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

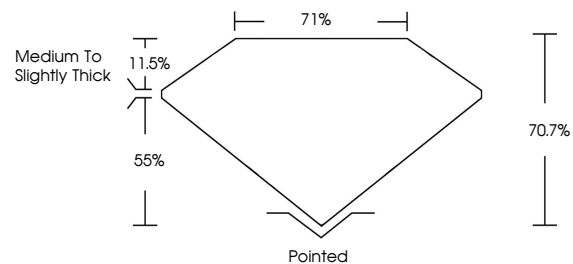
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **LG632438802**

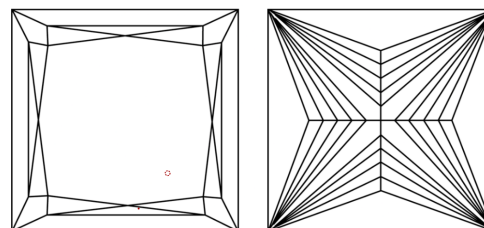
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

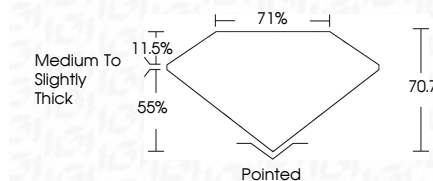
**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF VS<sup>1-2</sup> VS<sup>1-2</sup> SI<sup>1-2</sup> I<sup>1-3</sup>

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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**IGI**



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IGI Report No. **LG632438802**  
**PRINCESS CUT**

**2.04 CARATS**  
E  
2.04 CARATS

Carat Weight **2.04 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**  
Depth **70.7%**  
Table **71%**  
Girdle **Medium to Slightly Thick**

Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
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